Application No. 10/722,839 Amd. Under Rule 312 Dated October 3, 2005 Response to Allowance mailed August 2, 2005

In re the application of:



**PATENT** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Bright et al.

Application No: 10/722,839

Filed: November 25, 2003

For: APPARATUS FOR
CONTROLLING WAFER TEMPERATURE)
IN CHEMICAL MECHANICAL
POLISHING

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CERTIFICATE OF MAILING

Examiner: G.B.M. Nguyen

Attorney Docket: LAM2P318D

Group Art Unit: 3723

Date: October 3, 2005

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Box 1450, Alexandria, VA 22313-1450, on October 3, 2005.

Signed:

<u>AMENDMENT UNDER RULE 312</u>

Mail Stop IF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Following receipt of a Notice of Allowance, please amend the specification of the captioned application and consider the following remarks.

Amendments to the specification start on page 2 of this paper.

Remarks begin on page 3 of this paper.

Docket No: LAM2P318D Page 1 of 3